



PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.2444-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Hiroshi TOYODA, et al. ) Group Art Unit: 2814  
)  
Application No.: 10/600,568 ) Examiner: Weiss, Howard  
)  
Filed: June 23, 2003 )  
)  
For: METHOD OF MANUFACTURING )  
SEMICONDUCTOR DEVICE )  
INCLUDING TWO-STEP )  
POLISHING OPERATION FOR CAP )  
METAL (As Amended Herein) )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

In reply to the Office Action of January 12, 2004, with a period for response extending through April 12, 2004, please amend the application as follows. Applicants also respectfully request the Examiner's reconsideration in view of the remarks that follow:

**An Amendment to the Title** is shown on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims beginning on page 3 of this paper.

**Remarks** begin on page 7 of this paper.

**AMENDMENT TO THE TITLE:**

Please amend the title of the application as follows. On page 1, please replace the title at lines 2 and 3 with the following title:

--METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE INCLUDING  
TWO-STEP POLISHING OPERATION FOR CAP METAL AND SEMICONDUCTOR  
DEVICE--